

Optics Modeling and Simulation at APS —Hybrid method combining ray tracing and wavefront propagation

Xianbo Shi Optics Group, X-ray Science Division Advanced Photon Source

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Outline

- Motivation
- Hybrid method
 - Combining ray tracing and wavefront propagation
 - Including mirror figure error
- Beamline design
 - In Situ Nanoprobe (ISN) beamline at APS
- Summary

Motivation

- New light sources and upgrades with higher brightness, shorter pulse lengths, smaller emittance and partial or full coherence
- New experimental techniques: nano-scale imaging/ diffraction/ spectroscopy, ultrafast/time resolved experiments, coherent diffraction imaging.

Optics simulation and modeling

- Geometrical ray tracing, e.g., SHADOW
 - Total intensity, beam size, mirror figure errors, reflectivity
 - Fast, robust, parameter optimization
- Wavefront propagation
 - Fourier optics, e.g., SRW
 - Stationary phase, e.g., PHASE
 - Field amplitude and phase, diffraction effect and beam coherence
 - Partial coherent source: multi-electron simulation

Combining ray tracing and wavefront propagation



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- Source: $\sigma = 2 \mu m$ $\sigma' = 30 \mu rad$ E = 10 keV
- Elliptical cylinder mirror Mirror length *l* = 200 mm Grazing angle at mirror center: θ₀ = 2.5 mrad Demagnification: 150:1

Angle correction and intensity scaling



Angle correction and intensity scaling: effects on image



No slope error

Ray tracing + diffraction

- Slope error: 0.3 µrad
- Ray tracing + diffraction
- Ray tracing + diffraction + angle correction
- Ray tracing + diffraction + intensity scaling
- Ray tracing + diffraction + angle correction + intensity scaling



Figure error frequencies - Grating effect



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Grating equation: $\Delta x = q\lambda/d$, $d = l\sin\theta/n$

Figure error frequencies - PSD



Figure error frequencies - PSD



Comparison with pure ray tracing



In Situ Nanoprobe beamline



Photon (10 keV)	Electron	Total
$\sigma_r = 3.86 \ \mu m$	$\sigma_x=274.3\;\mu m$	$\sigma_x = 274.3 \ \mu m$
	$\sigma_y = 10.3 \ \mu m$	$\sigma_y = 11.0 \ \mu m$
$\sigma_{\xi} = 5.11 \ \mu rad$	$\sigma'_x = 11.27 \ \mu rad$	$\sigma'_x = 12.4 \ \mu rad$
	$\sigma'_{y} = 3.58 \mu rad$	$\sigma'_{y} = 6.24 \ \mu rad$

Source: undulator A, 3.3 cm, 72 periods, K = 0.906, B = 0.294 T

VFM: 400 mm long, 2.5 mrad grazing angle SSA: $11 \times 4 \ \mu m^2$ (h \times v)

VKB: 180 mm long, 2.5 mrad grazing angle HKB: 60 mm long, 2.5 mrad grazing angle

Comparison with SRW (multi-electron)



KB mirror slope error studies



Beam profiles along longitudinal direction



Summary

- ✓ The hybrid method combining ray tracing and wavefront propagation is demonstrated and compared with existing codes. It will be implemented in SHADOW.
- ✓ The effects of mirror figure error are studied. A bank of real metrology data will greatly benefit the community.
- Full 2-D simulation is needed for certain cases (toroid mirror).
- Coherence properties are the next focus.

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